

<b>Form PTO-1449</b> (modified) List of Patents and Publications For Applicant's Information Disclosure Statement (Use several sheets if necessary)	<i>SEP 10 2006</i> ATTN. DKT. NO. 5589-06501	SERIAL NO. 10/619,943 GROUP: 2621
APPLICANT: Peterson et al. FILING DATE: July 15, 2003		

## **U.S. PATENT DOCUMENTS**

## **FOREIGN PATENT DOCUMENTS**

EXAM. INITIALS	REF. DES.	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	TRANSLATION YES/NO
49	C2	1 093 017	2001-04-18	EP			

**OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)**

<i>F</i>	C3	Budd et al., "A New Mask Evaluation Tool, the Microlithography Simulation Microscope Aerial Image Measurement System," SPIE Vol. 2197, 1994, pp. 530-540.
<i>KY</i>	C4	Schurz et al., "Simulation Study of Reticle Enhancement Technology Applications for 157 nm Lithography," SPIE Vol. 4562, 2002, pp. 902-913.
<i>KY</i>	C5	Martino et al., "Application of the Aerial Image Measurement System (AIMS™) to the Analysis of Binary Mask Imaging and Resolution Enhancement Techniques," SPIE Vol. 2197, 1994, pp. 573-584.
<i>KY</i>	C6	International Search Report, application no. PCT/US03/21907, mailed June 7, 2004.

**EXAMINER:**

*Mr. Z*  
al if citation considered whether

**DATE CONSIDERED:**

12-28-06

**EXAMINER:** Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the patent owner.

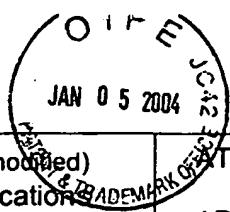


## ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0

Title of Invention	QUALIFYING PATTERNS, PATTERNING PROCESSES, OR PATTERNING APPARATUS IN THE FABRICATION OF MICROLITHOGRAPHIC PATTERNS						
Application Number:	10/619943						
Confirmation Number:	6799						
First Named Applicant:	Ingrid Peterson						
Attorney Docket Number:	5589-06501						
Search string:	( 6268093 or 6373975 ).pn.						
<b>US Patent Documents</b>							
Note: Applicant is not required to submit a paper copy of cited US Patent Documents							
init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
1	1	6268093	2001-07-31	Kenan et al.			
2	2	6373975	2002-04-16	Bula et al.			
<b>Signature</b>							
Examiner Name				Date			
				12-28-06			



**EXAMINER:**

the 3<sup>rd</sup>

**DATE CONSIDERED:**

12-78-06

**EXAMINER:** Initial if citation considered whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the patent owner.



## ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18  
Stylesheet Version v18.0

Title of Invention	QUALIFYING PATTERNS, PATTERNING PROCESSES, OR PATTERNING APPARATUS IN THE FABRICATION OF MICROLITHOGRAPHIC PATTERNS						
Application Number:	10/619943						
Confirmation Number:	6799						
First Named Applicant:	Ingrid Peterson						
Attorney Docket Number:	5589-06501						
Search string:	( 6701004 ).pn.						
<b>US Patent Documents</b>							
Note: Applicant is not required to submit a paper copy of cited US Patent Documents							
init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
KY	1	6701004	2004-03-02	Shykind et al.			
Signature							
Examiner Name				Date			
				12-28-06			